



Docket No. 740819-725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yasutoshi OKUNO et al.

Application No. 10/032,564

Filed: January 2, 2002

For: METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2823

) Examiner: Michelle Estrada

) Confirmation No. 5824

) Date: October 3, 2003

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: _____

Name: Deborah Movahhedi

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 3, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.

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